



Darryl Mexic
T 202-663-7909
Dmexic@sughrue.com

2100 Pennsylvania Avenue, NW
Washington, DC 20037-3213

T 202.293.7060
F 202.293.7860

www.sughrue.com

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MAIL STOP PATENT APPLICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Re: Application of Hidetsugu SHIMURA
APPARATUS AND METHOD OF FORMING PATCH IMAGE FOR
OPTIMIZING DENSITY CONTROL FACTOR
Assignee: **SEIKO EPSON CORPORATION**
Our Ref. Q76032

Dear Sir:

Attached hereto is the application identified above comprising one hundred sixteen (116) sheets of the specification, including the claims and abstract and thirty five (35) sheets of drawings. **The requisite U.S. Government Filing Fee, executed Declaration and Power of Attorney and Assignment will be submitted at a later date.** Also enclosed is an Information Disclosure Statement and PTO/SB/08 A & B (modified).

The Government filing fee is calculated as follows:

Total claims	<u>36</u>	-	20	=	<u>16</u>	x	\$18.00	=	\$288.00
Independent claims	<u>10</u>	-	3	=	<u>7</u>	x	\$84.00	=	\$588.00
Base Fee									\$750.00
TOTAL FEE									<u>\$1626.00</u>